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U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM 10035257	FILING DATE 01/04/2002	CLASS 438	SUBCLASS 627	GAU 2812	EXAMINER GUERRERO
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WONE MG  
\*\*CONTINUING DATA VERIFIED:

OK MG  
\*\* FOREIGN APPLICATIONS VERIFIED:  
REPUBLIC OF KOREA 2001-932 01/08/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO 262/014
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no	
Verified and Acknowledged Examiners's initials MG			
TITLE : Method of fabricating metal lines in a semiconductor device			

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner Application Examiner	
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